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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)		<b>Complete if Known</b>	
		Application Number	09/766,596
		Filing Date	1/23/2001
		First Named Inventor	Kato, et al.
		Art Unit	3749
Sheet 1 of	Attorney Docket Number	520.30414V22	

U.S. PATENT DOCUMENTS					
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	Document Number Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
11/3/05		US- 5,538,128	7/16/1996	Shimoyashiro, et al.	
		US-			
		US-			

FOREIGN PATENT DOCUMENTS						
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	Foreign Patent Document Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
11/3/05		JP 64-036042	2/7/1989	Kokusai Electric Co., Ltd.		

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
11/3/05		S. Nakagawa, "Dry Etching", Drafts in Symposium of VLSI and FA Technology, April 1985, pages 1-14	
11/3/05		N. Nagai, "Parallel-Implantation Ion Implantation Device "NH-20SP", Special Issue/Semiconductor Manufacturing Device of Half-Micron Age, pages 1-12, 3/1990	

Examiner Signature	<i>K. B. [Signature]</i>	Date Considered	11/3/05
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